

Docket No.: 60188-031

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Kentaro SHIOMI , et al.

Serial No.:

Filed: February 09, 2001

For: LSI DESIGN METHOD AND VERIFICATION METHOD

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: Group Art Unit:
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: Examiner:
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**CLAIM OF PRIORITY AND
TRANSMITTAL OF CERTIFIED PRIORITY DOCUMENT**

Commissioner for Patents
Washington, DC 20231


Sir:

In accordance with the provisions of 35 U.S.C. 119, Applicants hereby claim the priority of:

Japanese Patent Application No. 2000-034577,
filed February 14, 2000

Respectfully submitted,

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